In uence of G rain size on the E lectrical P roperties of Sb₂Te₃ P olycrystalline F ilm s.

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Resistance of vacuum deposited Sb_2Te_3 In s of thickness between 100-500nm has been measured in vacuum. It is found that the resistance of the polycrystalline In s strongly depends on the grain size and inter-granular voids. The charge carrier are shown to cross this high resistivity inter-granular void by ohm ic conduction. The barrier height as well as temperature coe cient of resistance are also shown to depend on the grain size and inter-grain voids.

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I. IN TRODUCTION

The transport mechanism and in turn the cause of resistance is of fundam ental in portance. Various model, especially for thin lm s, exist to understand the contribution from di erent scattering mechanism s. The lm resistance, how ever, may be due to a combination of three mechanism s, namely (i) due to scattering from phonons, in purities and point defects etc., (ii) from lm surface and (iii) due to grain boundaries which would be predominant in polycrystalline

In \pm . Dierent models exist to explain the dependence of resistance on Im thickness. In the case of scattering from the Im surface the variation from Im resistivity with Im thickness was given by the Fuchs-Sondheimer (F-S) relationship²

(d) =
$$_{0}$$
 1 + $\frac{l_{g}}{d}$ (1 p)

Where l_g is the mean free path, 'd' is the lm thickness and $_{\circ}$ the resistivity of the bulk sample. The constant 'p' indicates the fraction of electrons being relected from the surface. The value indicates the scattering mechanism, for example p=1 indicates specular relection. A similar relationship was established by M ayadas and Shatzkes (M - S)³ to explain the scattering from grain boundaries, with a very similar functional dependence with lm thickness. However, the model is limited to very thin lm s with an added restriction that the grain size are of the order of lm thickness. The grain boundary is de ned as region between two grains where crystal orientation changes. The transport properties of Sb₂Te₃ lm s like resistivity, H all coelecter, mobility and Seeback coelecter have been extensively studied^{4,5,6,7,8}, and reports in literature indicate lm s to be p-type with narrow band gap. However, all these reports are silent on the mechanism of scattering and in turn the source of resistivity. Only D am odara D as et al⁷ have reported resistivity as a function of thickness (50nm < d < 120nm). The article states average grain size to be of the order of lm thickness and indicates the scattering mechanism to be that of grain boundary scattering in

accordance to the M -S m odel. However, no report exists on the variation of resistance or resistivity of Sb_2Te_3 In s with grain size in thicker In s. This article investigates variation of resistance in In s whose thickness is enough to assume that the variation in resistivity is independent of defects and specular scattering.

II. EXPERIMENTAL

Films of Sb_2Te_3 were grown on glass substrates kept at room temperature, using therm all evaporation method. Sb₂Te₃ ingot of high purity (99.99%) supplied by Aldrich (USA) were used as the starting material. The crushed ingot were evaporated from molybdenum boat at a vacuum better than 10⁶Torr. The lm thickness was measured using Dektek IIA surface pro ler. The movem ent of the mechanical stylus across the edge of the lm determ ines the step height or the Insthickness. Indium contacts were grown on the glass substrates before they were placed in the chamber, such that a strip of Sb_2Te_3 Im of dimensions 2.3 cm 1:65mm could be fabricated on these contacts using a mask. The I-V characteristics of the Ims were measured by four probemethod. It was found to be linear between 25m V-24V, showing the ohm ic nature of indium contacts as well as the polycrystalline lm for applied eld. The lm s' resistance were measured by an high input im pedance digital multimeter. The structural and compositional analysis of these Im swere done using Phillips PW 1840 X -ray di ractom eter and Shim adzu ESCA 750 (Electron Spectroscopy for Chemical Analysis). The Inswere found to be stoichiom etrically uniform over the area 5cm x 5cm as determined by ESCA carried out in various regions of the lm. The morphological analysis was done with JOEL 840 Scanning Electron M icroscope (SEM). The as grown Im s showed tendency of ageing, where the resistance of the Im varied with time and saturated to a constant value in couple of weeks. The results presented in this article are of In swhich had achieved such saturation.

III. RESULTS AND DISCUSSION

A. Variation Resistance with grain size

The average grain size was determined from both SEM micrographs and X-ray diractograms. The grain size was calculated using the FullW idth at HalfM axim a (FW HM) of X-Ray peaks¹⁰. The results of grain size found by both m ethods were in agreement. A plot between the lm thickness and grain size shows no trend (gl). This variation in grain size with lm thickness may be a result of not having perfectly identical conditions during lm evaporation. It also represents the random ness of the growth process. This shows that the average grain size is not proportional to the lm thickness and resistance or resistivity will have to be studied both as a function of thickness and grain size to resolve the main contributor in scattering mechanism. The F-S theory shows that the contributions from the surface leads to an inverse proportionality with thickness (equation 1), where the model is restricted to cases where the charge

carriers m ean free path is of the order of the lm thickness $(l_{f} d)$. However, since the samples in our study have thickness between 130-500nm, the lm thickness is far greater then the mean free path. Beyond this lim it one can assume the lm s resistivity to be same as that of the bulk, showing no further change with increasing lm thickness. Thus, lm's resistance in this lim it should only fall inversely with thickness. Figure 2 shows the resistance of aged Sb₂Te₃ lm s falling linearly with increasing thickness. It can be understood trivially, that for the resistance of the

In to vary linearly with thickness as shown in gure 2, the resistivity would have to show a parabolic relationship with In thickness. Another important contributor to resistance is the grain boundary. However, that too requires an inverse proportionality with thickness. This lack of trend may be due to the assumption in M-S theory that the grain size is proportional to the In thickness, which is not the case here. It is clear that in the present study the surface scattering and grain boundary scattering do not contribute to the In resistance. Hence, to investigate the in uence of the grain size on transport properties, variation of resistance with grain size was studied. Figure 3 shows the variation of In resistance with grain size. A stated earlier the average grain size was determined from both SEM micrographs and X-ray di ractogram s. The grain boundary is de ned as region between two grains where crystal orientation changes. The representative micrographs of Sb_2Te_3 in gure 4 how ever, show large distances between two grains. The grains tend to have the resistivity of the bulk, how ever, even if there is an inter-connectivity between two neighbouring grains this region will have high resistivity by purely geom etry of narrow ing¹¹. These voids, hence would de nitely contribute di erently from the de ned grain boundary in M-S theory.

Volger's model¹² assumes the lm to be made up of cubical grains of edge size 'a' arranged in an ordered manner, as shown in g. 5a, with equal spacing between the neighbouring grains. The inter-grain distances are dimensional are same along any one direction. Consider the lm has 'q' number of grains arranged regularly at equal inter-grain spacing ${}^{0}t_{x}^{0}$ along the length 'I' and 'r' and 'p' grains arranged along the width and thickness of the lm. Also, the resistance is measured along the length of the lm by taking the contacts across the cross-section in the yz plane, then the points A-B, C-D etc. shown in g. 5a are at equal potential. The equivalent dc circuit of this arrangement of measurement would be as shown in gure 5b, where ${}^{0}R_{b}^{0}$ represents the high resistance of the inter-grain voids^{13,14,15}. As can be seen in gure 5b, the whole lm can be considered to be a parallel combination of 'pr' resistive elements, where resistance of each element is given by^{11,16,17}

$$R_1 = qR_q + (q \quad 1)R_b$$

Thus, the net resistance along the length of the Im between the two contacts would be given as

$$R_{net} = \frac{qR_g + (q \ 1)R_b}{pr}$$

Seto¹⁸ made a similar simplication step by assuming the problem to be that of one dimension. ${}^{0}R_{b}^{0}$, the high resistance of the inter-grain voids, is a function of ${}^{0}t_{x}^{0}$ which in turn would depend on the mechanism by which charge carriers would cross the inter-grain boundary. Many suggestions have been made for explaining the cross over, such

as ohm ic conduction, tunnelling or therm ionic em ission¹⁹. It m ay also be a combination of these, depending on the actual inter-grain distances. The resistance of such a \ln , assuming ohm ic conduction in between grains is given as²⁰

$$R_{net} = \frac{1 + kx}{(1 + x)^2}$$
(1)

where is a proportionality constant, given as

$$= \frac{gl^2}{V V_{void}}$$

In true sense is not a constant since V_{void} will depend on the grain size, as also in dimensions, including it's thickness. However, V_{void} is assumed to be a slow varying function of in thickness, or constant. The constant 'k' represents a ratio of the inter-grain region's resistivity to the grain's resistivity. Since the void resistivity is large, 'k' obviously is a very large entity. The variable is a ratio of the inter-grain length and the grain edge or

$$x = \frac{t_x}{a}$$

where 'a' is the grain size, assuming as in Volger's model, the grains to be cubic in nature. The inter-grain distance, ${}^{0}t^{0}_{x}$ is extent of void in 'x' direction (along length of the lm strip), since the resistance is measured along the length of the lm. The inter-grain distance varies as a function of the grain size depending the mechanism of grain grow th. Since, the Sb₂Te₃ lm s aged to a hexagonal crystal state, with c >> a, it should show easier grain grow th along the length and width as compared with that along restrictive lm thickness. The lm shence aged with the c-axis aligned norm al to the substrate plane²⁰. A sper Volger's model 'q', the grain number along the length, would be decreasing m ore rapidly than 'p', that along the lm 's thickness, leading to a general trend of decrease in resistance. Thus, the variation of inter-grain distance with grain size for the lm s in consideration would be given as²⁰

$$t_x = a \frac{pra^2 l V}{V pra^3}$$
(2)

where V = V V_{void} . Thus, it can be seen that the variable, is a function of the grain size, 'a'. The increase in void size with increasing grain size can be appreciated from the representative SEM m icrographs. Equation 2, is physically valid for positive values, which requires

$$pra^2$$
l> V > pra^3

Considering a extrem e case of $pra^2 l >> V >> pra^3$ along with the stated assumption that V is constant, then equation 2 m aybe written as

$$t_x = a \frac{pra^2 l}{V}$$

The variable 'x' required for equation (1) can then be expressed as

$$x = \frac{t_x}{a} = a^2 \quad \frac{\text{prl}}{V} = a^2 \tag{3}$$

This increase in inter-grain distance with growing grain size was discussed in our earlier work²⁰. Hence, using equation (3) the lm s resistance given by equation (1), can be expressed as

$$R_{net} = \frac{1 + k a^2}{(1 + a^2)^2}$$
(4)

Equation (4) ts quite well to the experimental observations as shown by the solid line in gure 4. The values of the constants evaluated by tting are = 2308 , = 20:44 10 6 A² and k 54. As stated earlier, the constant k is a ratio of the high resistivity of the inter-grain region as to the low resistivity of the grains. The numerical value shows the resistivity of the inter-grain region will be nearly 10^{2} times that of the low resistivity region, which is consistent with the with the assumption that inter-grain region can be assumed to be a path of high resistance.

B. Variation of Barrier H eight with grain size

The voids between neighbouring grains would present itself as a barrier which the charge carriers would have to transverse to establish current ow. The magnitude of the barrier height can be computed from the slope of the plot between $\ln()$ and temperature inverse (1/T in K elvin). The barrier height was calculated using this method for various \ln thickness. The variation is shown in gure 6. The variation in barrier height with \ln thickness maybe due to one or a cumulative elect of the following (i) variation in the grain size of the polycrystalline \ln , (ii) a large density of dislocations, (iii) quantum size elects and (iv) change in \ln stoichiom etry. Since the \ln thickness of this study is large the quantum size elect is immediately ruled out. Careful grow th technique followed by ageing would minim ise the contribution due to dislocation and o stoichiom etric compositions, how ever, can not be completely ruled out. The major contribution hence would be due to the size of the grains. Slater²¹ estimated the barrier height as a function of grain size by modelling grain boundary as a pn type of structure. The variation is given as

$$E_{b} = E_{o} + \frac{N_{o}e^{2}}{4k_{o}} \quad t_{x} \quad \frac{N_{o}}{N_{o}}a^{2}$$
(5)

where N_{\circ} is the doping concentration, N the carrier concentration, k the dielectric constant of the material. The barrier height increases with grain size for $N = N_{\circ} > t_x$, which would be the case in pure samples ($N > N_{\circ}$). A t for the experimental data using equation 3, which states that the barrier width in proportional to the square of the grain size, along with the estimated proportionality constant (b) and equation 5 is shown by the continuous line in gure 6. The t shows reasonable agreement, however it does indicate possible contributions from dislocations etc. The values of the coe cients of equation 5 are $E_{\circ} = 5.66 \text{m eV}$, $N = N_{\circ} = 90$ and $N_{\circ}e^2 = 4k_{\circ} = 2.65 = 10^{-9} \text{m eV}$ A^2 . The ratio of $N = N_{\circ}$ m ay appear to be very small, however, it should be noted that the curve tting was done using the earlier estimated proportionality constant (). Thus, the in uence of the inter-grain voids and grain size on the magnitude of barrier height and various characterising parameters of the line is evident. This though expected is dimensional to the magnitude of the section of the section of the section of the section of the magnitude of the section of the magnitude of the section of the section of the magnitude of the section of the section of the magnitude of the section of the sect

earlier study by Rajagopalan et al⁴ on $\ln s$ of Sb₂Te₃ with thickness between 160nm and 800nm which reported that the barrier height was independent of the \ln thickness. In the next section we investigate the role of the inter-grain voids on another parameter used to characterise the transport properties of a material.

C. Tem perature coe cient of R esistance

The resistance of the lm is a function of temperature. The variation of resistance with temperature in general is expressed as

$$R = R_{\circ} (1 + \frac{1}{R_{\circ}} T)$$

Thus the tem perature coe cient of resistance or TCR 22 is given as

$$\frac{1}{R_{o}}\frac{dR}{dT} = \frac{1}{R_{o}}$$
(6)

W hile TCR is positive form etals, it is negative in case of sem iconductors. The F-S model for very thin Im s states that the variation of TCR with Im thickness follows an identical form as expressed by equation (1). However, there seem s to be no model in the literature to explain the variation of TCR with either Im thickness or grain size for

In s with thickness greater than the mean free path of their charge carriers. A plot between TCR and grain size seem s scattered (not show n). However, the plot between TCR and barrier height is a straight line, gure 7, with slope $8:6 \quad 10^{-5} (^{\circ}C \mod ^{\circ}N)^{-1}$ and intercept $2:66 \quad 10^{-5} (^{\circ}C \pmod ^{\circ})$. It in mediately follows from the linearity between TCR and E_b along with equation (5) that the TCR would be a polynomial function of the grain size. This explains the seem ingly scattered data points of TCR with grain size as discussed. It also explains the lack of any model or theory on the variation of TCR with grain size. The relationship shows that with increasing barrier height, the rate of change of resistance with tem perature (dR/dT or TCR, equation 6) becomes increasingly smaller. The negative tem perature coe cient of resistance in sem iconductors is a result of increasing charge carriers due to breaking covalent bonds. An increased barrier height im plies its more di cult for the charge carriers to escape into the voids from the grains, con ning the increased number of carriers inside the grain itself. This rapidly brings down the resistance of the grain contributing to a negative TCR proportional to the barrier height.

IV. CONCLUSIONS

The dc transport properties of Sb_2Te_3 In swith thickness between 130-500nm have been discussed. The properties showed no size e ects as was expected, since the Im thickness was far greater than the charge carriers mean free path. The Im s resistance, the barrier height and tem perature coe cient of resistance (TCR) showed a strong dependence

on both the grain size and inter-grain void. The inter-grain void was approximated to vary with increasing grain size, enabling to study the above properties of the lm s as a function of grain size.

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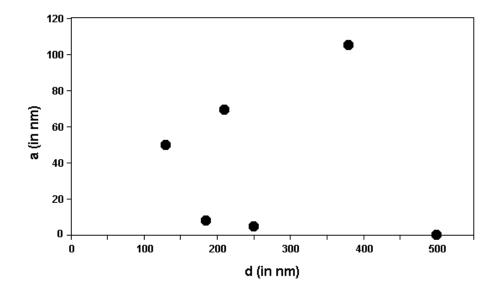
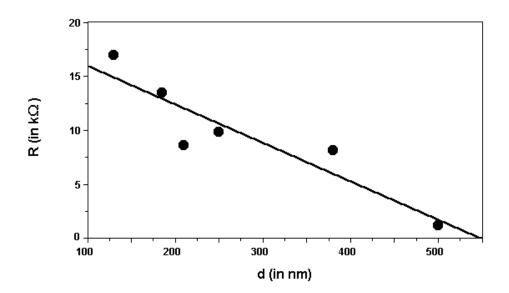


FIG.1: The variation of grain size in the polycrystalline lm s for various thickness of Sb₂Te₃ grown by therm all evaporation m ethod, show no trend.



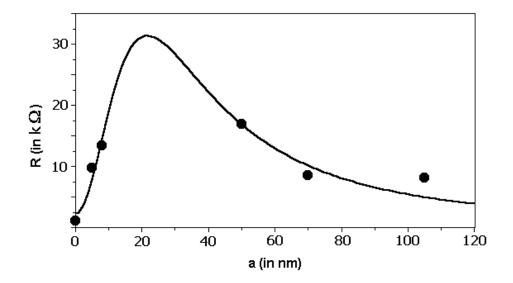


FIG.3: Variation of lm resistance with grain size of various polycrystalline Sb₂Te₃ lm s. The continuous curve is a tof the experimental points using equation (4).

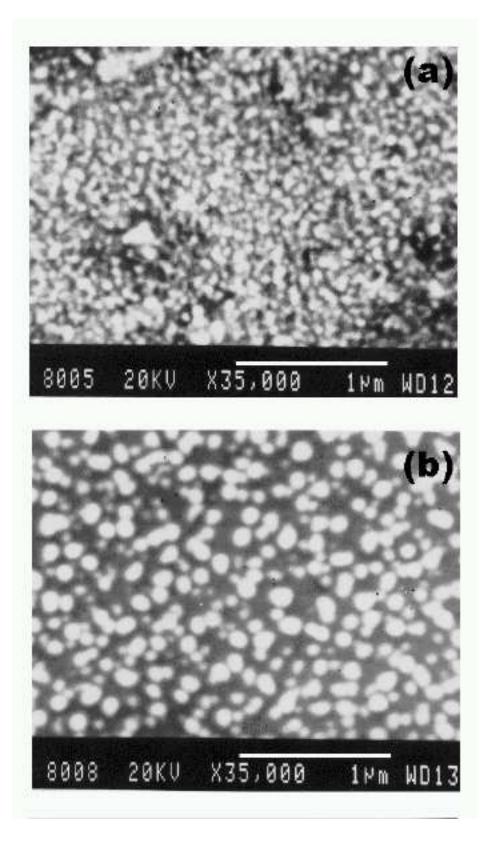


FIG.4: SEM micrographs of two lm swith di erent thickness (a) 130nm and (b) 380nm, showing grains with voids between neighbouring grains. It is evident that as grain size increases the voids also increase.

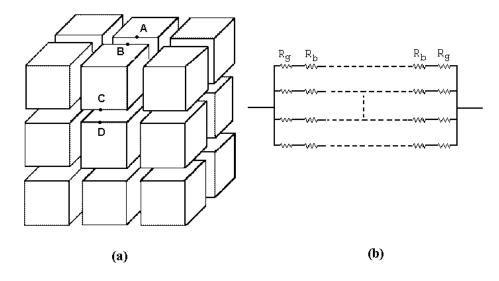


FIG. 5: Figure shows (a) an idealised assumption of how cubic grains are arranged along the dimensions of a polycrystalline Im and (b) shows an equivalent circuit of the a polycrystalline Im based on simpli ed assumptions.

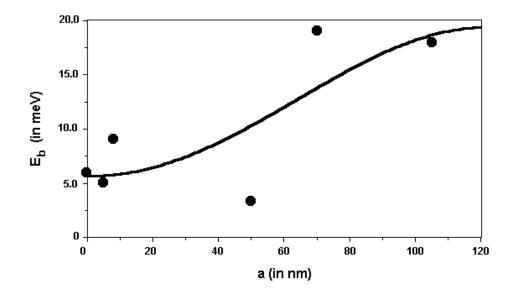


FIG. 6: Plot shows the variation of energy barrier height with improving grain size. The continuous curve is a t of the experim ental point using Slater's model (equation 5). The scattered points indicate other in uences also on the barrier height.

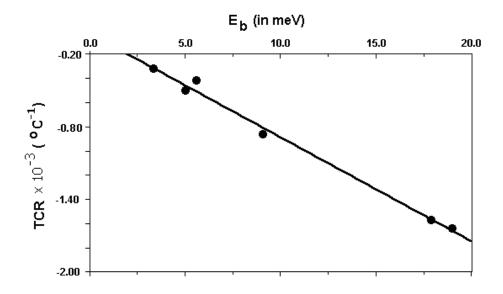


FIG.7: The linear variation of tem perature coe cient of resistance (TCR) with the barrier height in plies the dependence of with the grain size.